

Notice of References Cited	Application/Control No. 10/649,598	Applicant(s)/Patent Under Reexamination KIM, SUN-TAI	
	Examiner Anatoly Vortman	Art Unit 2835	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2004/0041521	03-2004	Mandler et al.	313/512
	B	US-2004/0022057	02-2004	Lee, Gye Seon	362/238
	C	US-2003/0202349	10-2003	Suehiro et al.	362/245
	D	US-2003/0167666	09-2003	Close, Richard A. JR.	40/452
	E	US-2002/0093832	07-2002	Hamilton, Alan James	362/555
	F	US-2002/0030992	03-2002	Lefebvre et al.	362/243
	G	US-5,276,591	01-1994	Hegarty, William	362/31
	H	US-5,526,236	06-1996	Burnes et al.	362/20
	I	US-5,842,297	12-1998	Tung, Ching-Yung	40/546
	J	US-5,950,340	09-1999	Woo, Fay Kan-Kyone	40/564
	K	US-6,481,130	11-2002	Wu, Chen-Ho	40/546
	L	US-5,808,592	09-1998	Mizutani et al.	345/83
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	DE 19741585 C1	10-1998	Germany	BAVENDIEK et al.	H01L 25/075
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.